Sheet 1 of 1

Form PTO-1449 (REV. 8-83)	US Dept. of Commerce PATENT & TRADEMARK OFFICE	ATTY DOCKET NO. 118749	APPLICATION NO. New US Application
INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)		APPLICANTS Isao YOKOKAWA et al.	
		FILING DATE February 23, 2004	

U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS
AL	1	JP A 11-307472 (with abstract and translation)	11/05/1999	Japan		
AL	2	JP A 5-211128 (with abstract and translation)	08/20/1993	Japan		

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)

	3	Eltran et al, "Science in Silicon", Surface Science Technology Series, Realize Inc., pp 443-496

EXAMINER	DATE CONSIDERED
	6/8/05

Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Date: February 23, 2004